10009446WO01





PCT REQUEST

Original (for SUBMISSION)

0	For receiving Office use only				
0-1	International Application No.				
0-2	International Filing Date				
0-3	Name of receiving Office and "PCT International Application"				
0-4	Form PCT/RO/101 PCT Request				
0-4-1	Prepared Using	PCT-SAFE [EASY mode] Version 3.50 (Build 0002.170)			
0-5	Petition				
	The undersigned requests that the present international application be processed according to the Patent Cooperation Treaty				
0-6	Receiving Office (specified by the applicant)	Japan Patent Office (RO/JP)			
0-7	Applicant's or agent's file reference	10009446W001			
1	Title of Invention	SILICON LAYER PRODUCTION METHOD AND SOLAR CELL PRODUCTION METHOD			
13	Applicant				
I I -1	This person is	applicant only			
11-2	Applicant for	all designated States except US			
11-4	Name	CANON KABUSHIKI KAISHA			
II-5	Address	3-30-2, Shimomaruko, Ohta-ku, Tokyo 1468501 Japan			
I - 6	State of nationality	JP			
I-7	State of residence	JP			
13-8	Telephone No.	03-3758-2111			
11-9	Facsimile No.	03-3756-0947			
D-1	Applicant and/or inventor	V3-3/30-V31/			
11-1-1	This person is	applicant and inventor			
II-1-2	Applicant for	US only			
11-1-4	Name (LAST, First)	MIZUTANI, Masaki			
II-1-5	Address	c/o CANON KABUSHIKI KAISHA, 3-30-2, Shimomaruko, Ohta-ku, Tokyo 1468501			
	04-1-4-1-1-1	Japan			
11-1-6	State of nationality	JP			
lli-1-7	State of residence	JP			

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111-2	Applicant and/or inventor			
III-2-1	This person is	applicant and inventor		
111-2-2	Applicant for	US only		
111-2-4	Name (LAST, First)	NISHIDA, Shoji		
III-2-5	Address	c/o CANON KABUSHIKI KAISHA, 3-30-2, Shimomaruko, Ohta-ku, Tokyo 1468501 Japan		
111-2-6	State of nationality	JP		
111-2-7	State of residence	JP		
111-3	Applicant and/or inventor			
111-3-1	This person is	applicant and inventor		
111-3-2	Applicant for	US only		
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III-3-5	Address	c/o CANON KABUSHIKI KAISHA, 3-30-2, Shimomaruko, Ohta-ku, Tokyo 1468501 Japan		
111-3-6	State of nationality	JP		
111-3-7	State of residence	JP		
IV-1	Agent or common representative; or address for correspondence The person identified below is hereby/ has been appointed to act on behalf of the applicant(s) before the competent	agent		
IV-1-1	International Authorities as: Name (LAST, First)	OWEN W		
IV-1-2	Address	OKABE, Masao		
	Address	No. 602, Fuji Bldg., 2-3, Marunouchi 3-chome, Chiyoda-ku, Tokyo 1000005 Japan		
IV-1-3	Telephone No.	03-3213-1561		
IV-1-4	Facsimile No.	03-3214-0929		
IV-2	Additional agent(s)	additional agent(s) with same address as first named agent		
IV-2-1	Name(s)	KATO, Nobuaki; UBUKATA, Kazuo; OKABE, Yuzuru; USUI, Shinichi; FUJINO, Ikuo; OCHI, Takao; MOTOMIYA, Teruhisa; TAKANASHI, Norimichi; ASAHI, Nobumitsu; TAKAHASHI, Seiichiro; YOSHIZAWA, Hiroshi; MATSUI, Takao; KOBAYASHI, Tsuneo; SAITO, Masami; MIYAMA, Katsumi		

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V	DESIGNATIONS				
V-1 .	The filing of this request constitutes under Rule 4.9(a), the designation of all Contracting States bound by the PCT on the international filing date, for the grant of every kind of protection available and, where applicable, for the grant of both regional and national patents.				
VI-1	Priority claim of earlier national application	·			
VI-1-1	Filing date	27 May 2004 (27.05.2004)			
VI-1-2	Number	2004-156968			
VI-1-3	Country	JP			
VI-2	Priority document request	document request			
	The receiving Office is requested to prepare and transmit to the International Bureau a certified copy of the earlier application(s) Identified above as item(s):	VI-1	• .		
VII-1	International Searching Authority Chosen	Japan Patent Office (ISA/JP)			
VIII .	Declarations	Number of declarations			
VIII-1	Declaration as to the identity of the Inventor	-	·		
VIII-2	Declaration as to the applicant's entitlement, as at the international filing date, to apply for and be granted a patent	•			
VIII-3	Declaration as to the applicant's enti tlement, as at the international filing date, to claim the priority of the earlier application	-	•		
/iII-4	Declaration of inventorship (only for the purposes of the designation of the United States of America)	-			
/III-5	Declaration as to non-prejudicial disclosures or exceptions to lack of novelty	-			
X	Check list	number of sheets	electronic file(s) attached		
X-1	Request (including declaration sheets)	4	✓		
X-2	Description	17	-		
X-3	Claims	2			
X-4	Abstract	1	✓		
X-5	Drawings	2	-		
X-7	TOTAL	26			

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	Accompanying Items	paper document(s) attached	electronic file(s) attached	
8	Fee calculation sheet	/	•	
9	Original separate power of attorney	√	•	
17	PCT-SAFE physical media	-	✓	
18	other	Revenue Stamps		
-18	other	Receipt of the fees paid to deposit account of WIPO		
-19	Figure of the drawings which should accompany the abstract	2	·	
-20	Language of filing of the international application	English		
1	Signature of applicant, agent or common representative			
1-1	Name (LAST, First)	KOBAYASHI, Tsuneo		
1-2 1-3	Name of signatory Capacity			

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10-1	Date of actual receipt of the purported international application				
10-2	Drawings:				• • • • • • • • • • • • • • • • • • • •
10-2-1	Received				
10-2-2	Not received			_	
10-3	Corrected date of actual receipt due to later but timely received papers or drawings completing the purported international application				
10-4	Date of timely receipt of the required corrections under PCT Article 11(2)				
10-5	International Searching Authority	ISA/JP	:		
10-6	Transmittal of search copy delayed until search fee is paid				

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